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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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| Complete if Known      |                        |  |  |  |
|------------------------|------------------------|--|--|--|
| Application Number     | 10/664,796             |  |  |  |
| Filing Date            | 09/18/2003             |  |  |  |
| First Named Inventor   | Jacob Johannes Scholtz |  |  |  |
| Art Unit               |                        |  |  |  |
| Examiner Name          |                        |  |  |  |
| Attorney Docket Number | F124C1                 |  |  |  |

|                       |                          |  | U. S. PATEN                    | DOCUMENTS  |   |
|-----------------------|--------------------------|--|--------------------------------|--|---|
| Examiner<br>Initials* | Cite<br>No. <sup>1</sup> | Document Number  Number-Kind Code <sup>2 (f trown)</sup> | Publication Date<br>MM-DD-YYYY | Name of Patentee or<br>Applicant of Cited Document | Pages, Columns, Lines, Where<br>Relevant Passages or Relevant<br>Figures Appear |
| 86                    | Α                        | <sup>US-</sup> 6,365,896                                 | 04-02-2002                     | Van der Mast                                       |   |
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| PG                    | D                        | <sup>US-</sup> 5,578,821                                 | 11-26-1996                     | Meisberger et al.                                  |   |
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|                       | FOREIGN PATENT DOCUMENTS |   |                     |  |   |    |  |  |
|-----------------------|--------------------------|---|---------------------|--|---|----|--|--|
| Examiner<br>Initials* | Cite<br>No.1             | Foreign Patent Document   | Publication<br>Date | Name of Patentee or<br>Applicant of Cited Document | Pages, Columns, Lines,<br>Where Relevant Passages | T6 |  |  |
|                       |                          | Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known) | MM-DD-YYYY          |  | Or Relevant Figures Appear                        | L' |  |  |
| PG                    | E                        | JP05-174768 Pat. Abstract of Japan  | 07-13-1993          | Nikon Corp.  |   |    |  |  |
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| Qubsilie                     | 10 10 10 10 10 10 10 10 10 10 10 10 10 1 |           |           | Application Number     | 10/664,796             |  |
| INFO                         | ORMATION                                 | N DIS     | CLOSURE   | Filing Date            | 09/18/2003             |  |
| STATEMENT BY APPLICANT       |  |           | PPLICANT  | First Named Inventor   | Jacob Johannes Scholtz |  |
|                              | // to a a manu ah                        |           |           | Art Unit               |                        |  |
|                              | (Use as many sh                          | eers as n | ecessary) | Examiner Name          |                        |  |
| Sheet                        | 2  | of        | 2         | Attorney Docket Number | F124C1                 |  |

| NON PATENT LITERATURE DOCUMENTS |                          |   |        |  |  |  |
|---------------------------------|--------------------------|---|--------|--|--|--|
| Examiner<br>Initials*           | Cite<br>No. <sup>1</sup> | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T²     |  |  |  |
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